

ABSTRACT

5

MONITORING DEVICE AND METHOD

This invention is related to monitoring device and method. In particular, the invention relates to a device and method for monitoring conditions in the ground or in a building
10 structure. In an aspect of the invention, there is provided a monitoring module comprising a processing unit electrically connected to a first line of sensors, the first line of sensors comprising a plurality of inertial measurement units (IMUs) adapted to determine a profile of a structure along a length of the first line of sensors.

15 Fig. 3